

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 25, 2025

IGI Report Number

LG702520787

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE BRILLIANT

Measurements

16.62 X 8.42 X 5.18 MM

GRADING RESULTS

Carat Weight

4.09 CARATS

Color Grade

E

Clarity Grade

VS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence


NONE

Inscription(s)

 LG702520787

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

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
Symmetry

EXCELLENT

Fluorescence

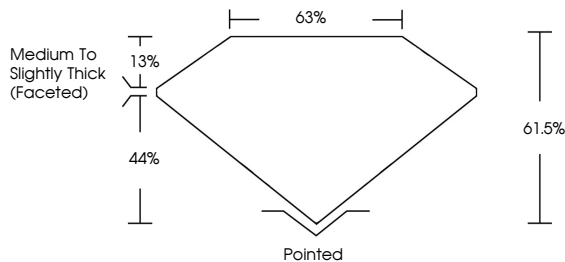
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PROPORTIONS



Medium To Slightly Thick (Faceted)

63%

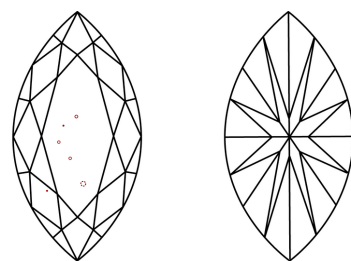
13%

44%

61.5%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS



Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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
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